

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Wen-Yen Hwang

Serial No.: 09/993,239

Filed: 11/13/2001

For: Method for Fabricating a VCSEL with  
Ion-Implanted Current-Confinement  
Structure

§ Group Art Unit: 2828  
§  
§ Examiner: Davie, James W.  
§  
§ Atty. Docket No.: PAT034US  
§  
§ Confirmation No.: 6902  
§  
§  
§

MAIL STOP ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**CERTIFICATE OF MAILING BY FIRST CLASS MAIL**  
**DATE OF DEPOSIT: April 28, 2005**

I hereby certify that this correspondence is being deposited  
with the United States Postal Service with sufficient  
postage as First Class Mail on the date indicated above  
and is addressed to Commissioner for Patents, P.O. Box  
1450, Alexandria, VA 22313-1450.

  
N. STEPHAN KINSELLA

**TRANSMITTAL LETTER**

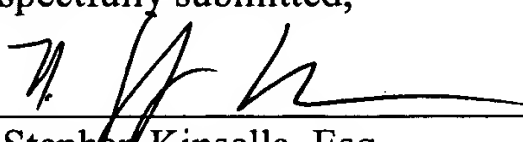
Enclosed for filing in the referenced case please find the following:

1. Part B - Issue Fee Transmittal (in duplicate).
2. Drawing Transmittal Letter;
3. 1 Corrected Sheets of Formal Drawings; and
4. Return Postcard.


The Commissioner is hereby authorized to charge any deficiency or credit any overpayment  
to Deposit Account No. 50-1705 in association with this filing.

Respectfully submitted,

Date: April 28, 2005

  
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